

12/11/01

Case No. 00CT1895324

**DIRECTOR,
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Transmitted herewith for filing is the patent application of:

12-14-01
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DATE OF DEPOSIT: December 11, 2001

NAME: DAWN KIMLER

SIGNATURE: 

Inventors: COFFA, Salvatore
OCCHIPINTI, Luigi

For: PRESSURE SENSOR MONOLITHICALLY INTEGRATED AND
RELATIVE PROCESS OF FABRICATION

12-14-01
 J-503 U.S. PTO


Please Note the Following:

Patent Application: 15 pages, 8 claims
 4 sheets of drawings

The suggested drawing figure to be published is FIG. 3h.

Citation Under 37 CFR 1.97 and PTO-1449

A Preliminary Amendment

Submission of Proposed Drawing Modification.

A certified copy of an Italian application.

Assignee info:

Name: STMicroelectronics S.r.l.
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Country of Incorporation: Italy

Applicant claims priority benefit to the following foreign application(s):

Country: Italy

Application No.: VA 2000A000042

Filing Date: December 15, 2000

The Declaration and Filing Fee are NOT ENCLOSED.

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